# Photocathode characterisation device Status

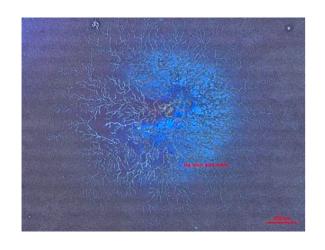
**Florian M. Brunbauer** on behalf of the CERN EP-DT-DD GDD group

September 26, 2017

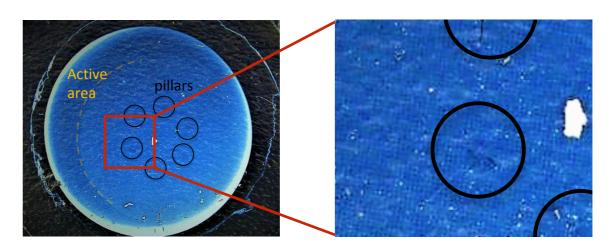
### New materials

### Photocathodes

#### **Spark on Csl photocathode**



#### Ion feedback on CsI photocathode



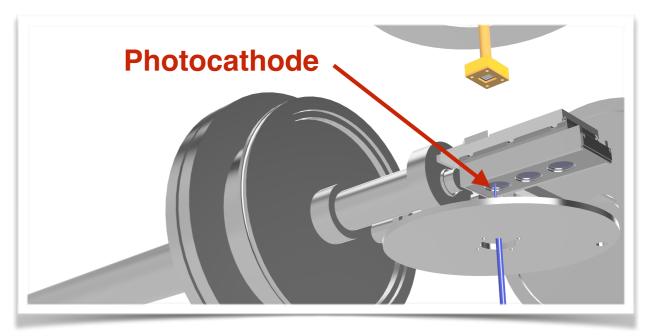
Csl photocathodes are sensitive to **sparks** and ion **bombardment** 

#### **Robust photocathode:**

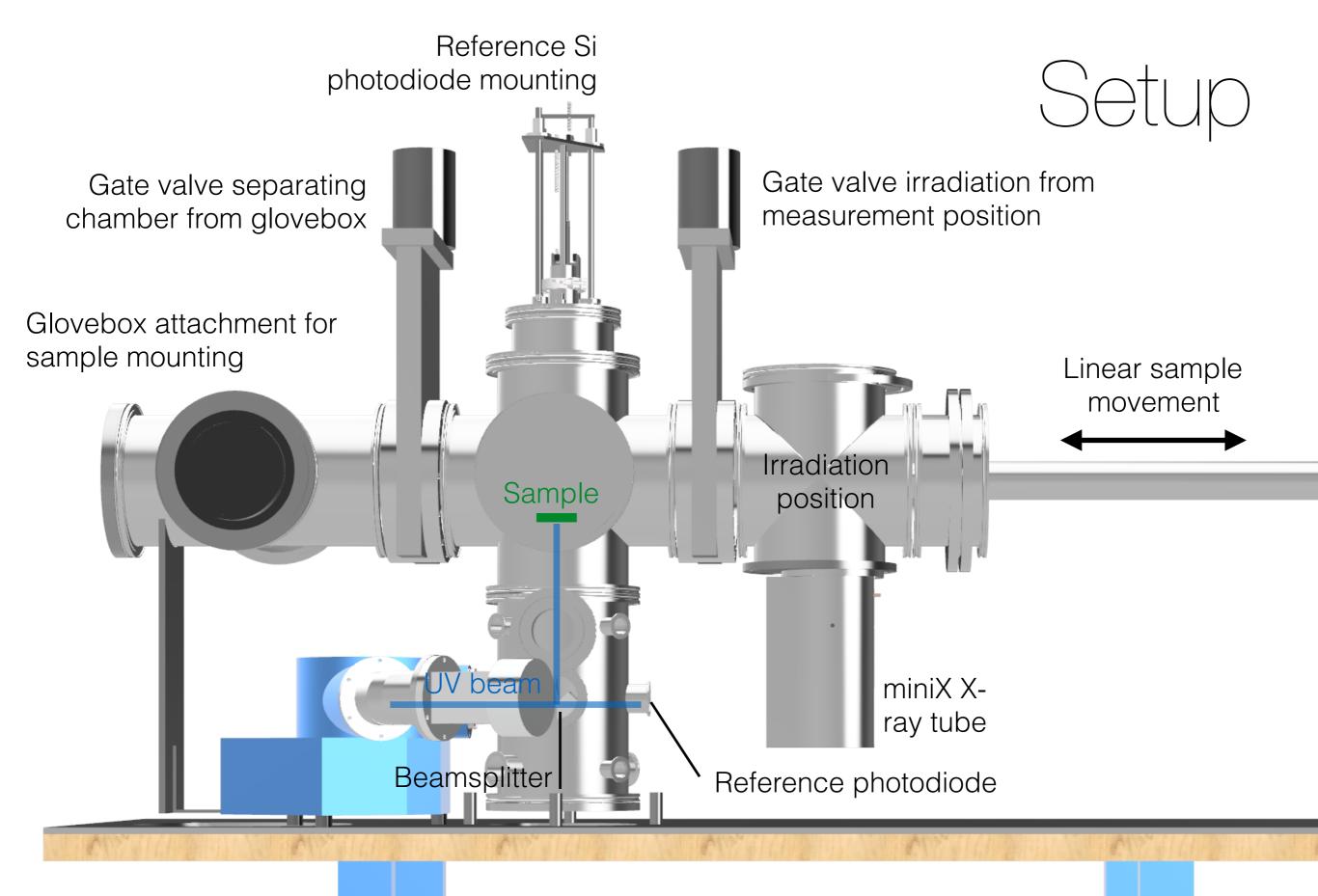
- Diamond as photocathode
  DLC photocathode
- Purely metallic photocathodes
  Chromium, aluminum already tested

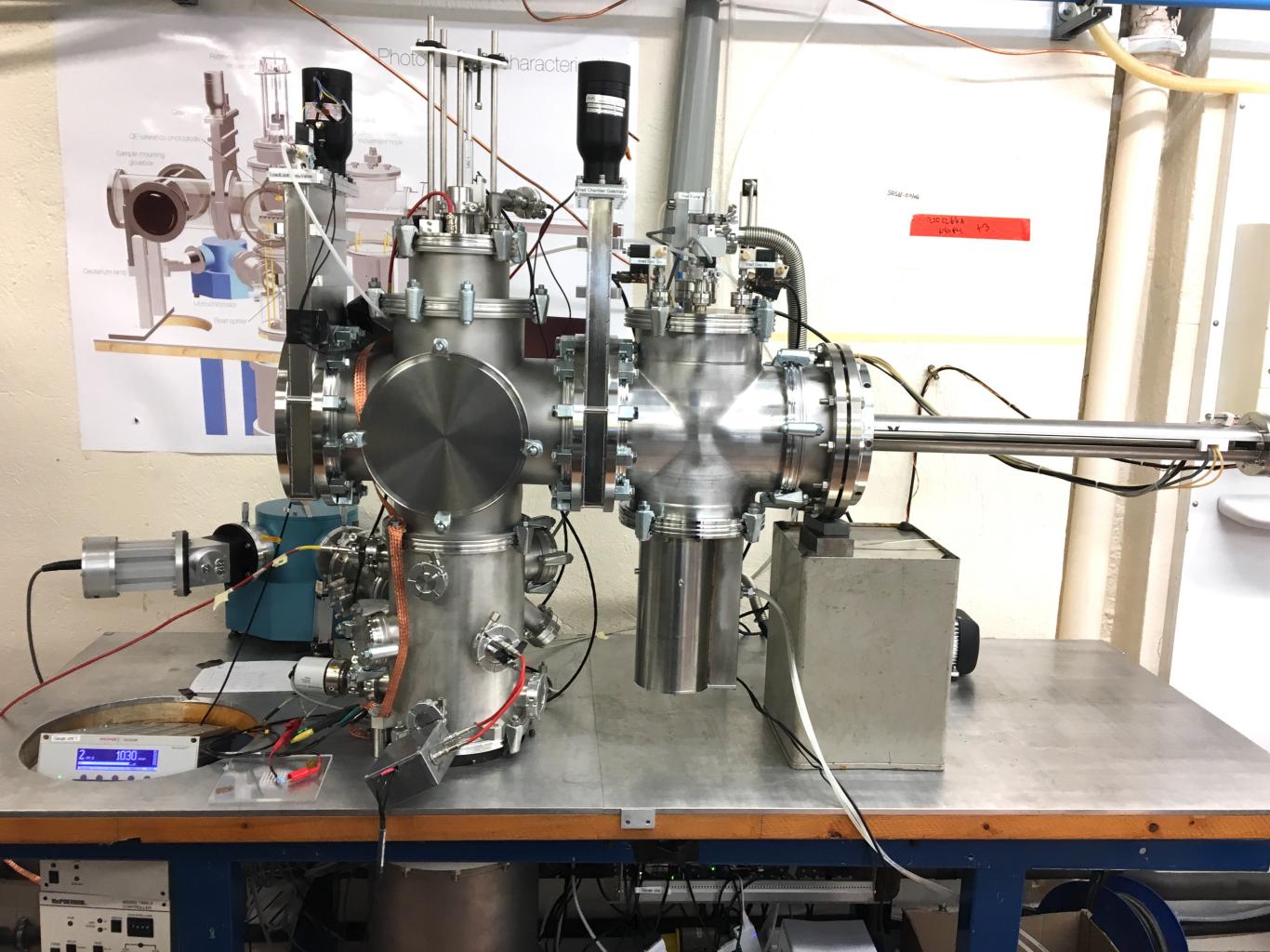
#### **Protecting Csl photocathode by:**

- Thin layers applied by ALD
- LiF protection layer
- Graphene as protection layer

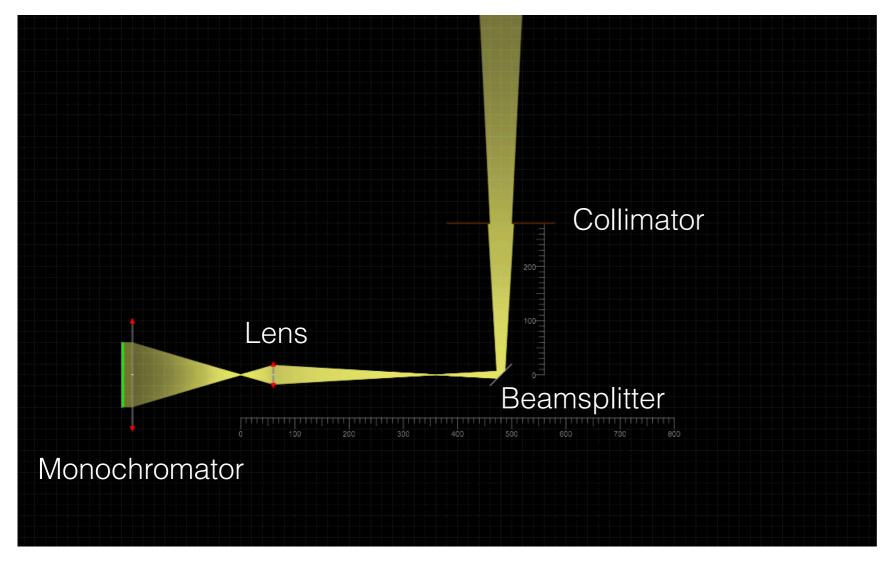


Development of photocathode characterisation device (ASSET) to study QE after **ion bombardment** and influence of **protection layers** 





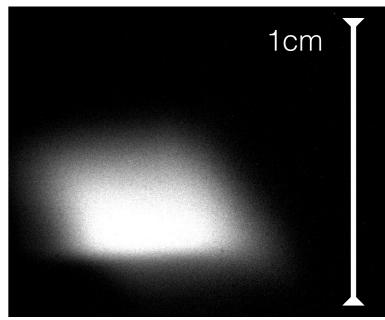
### UV beam



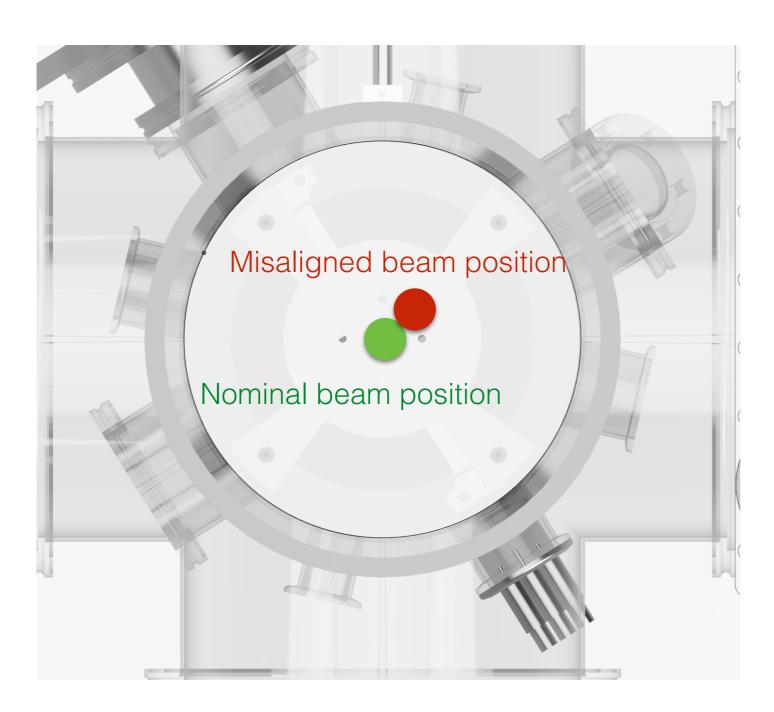
UV light path through lens and beamsplitter

UV beam (uncollimated) focused to ≈5x5mm size

**UV light beam profile**Recorded on CCD sensor



### UV beam

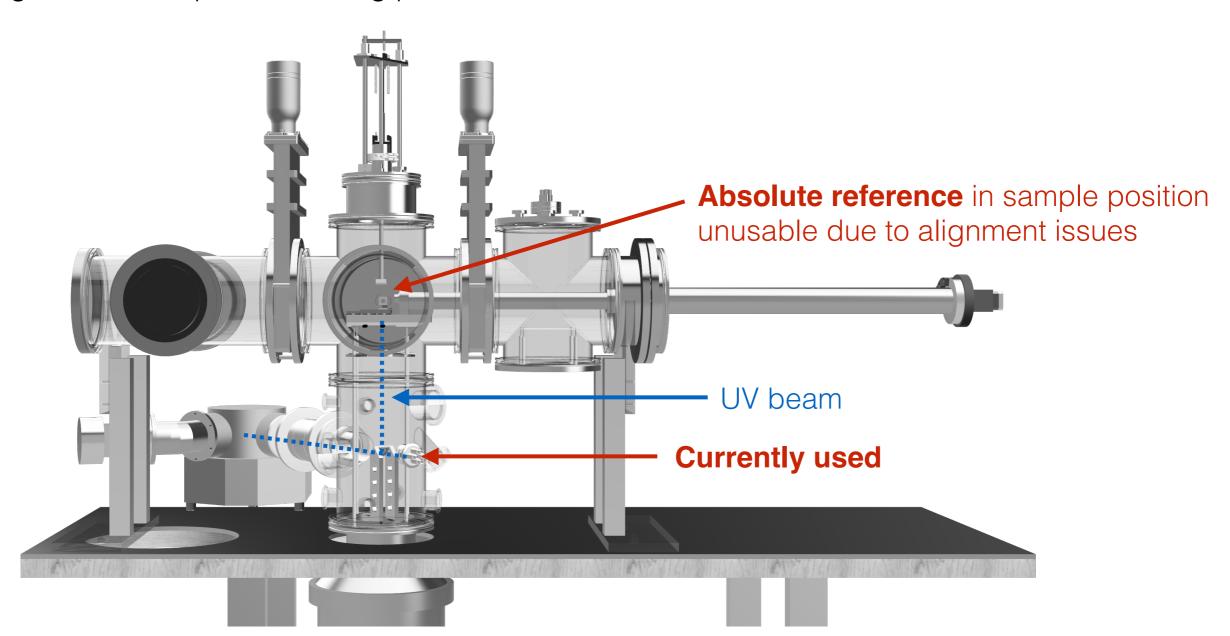


Alignment issue prevents using photodiode for absolute reference

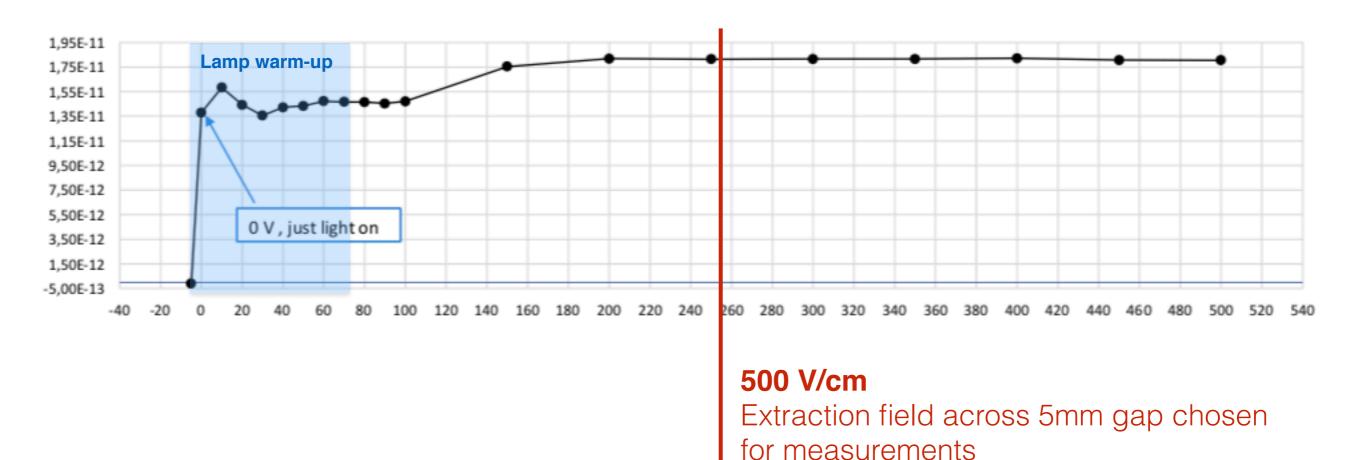
About 1cm **misalignment** from axis to the back-right

### First relative measurements

Alignment issue prevents using photodiode for absolute reference



### Extraction efficiency

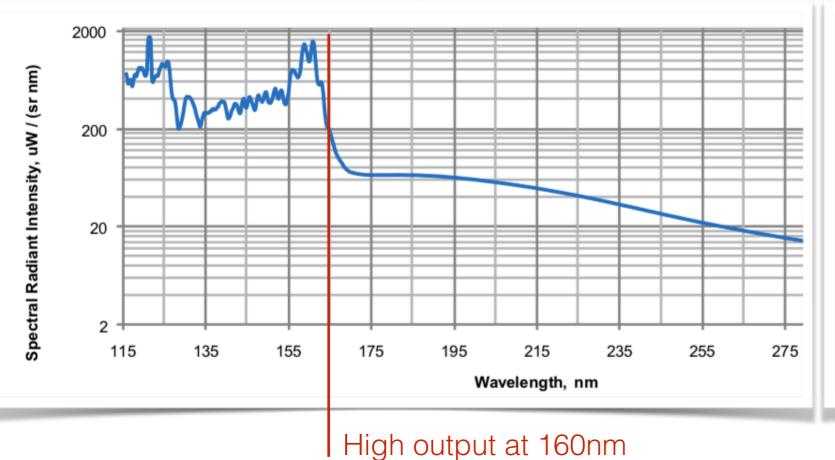


Initial rise not reflecting more extraction but attributed to warming-up period of lamp after switching on

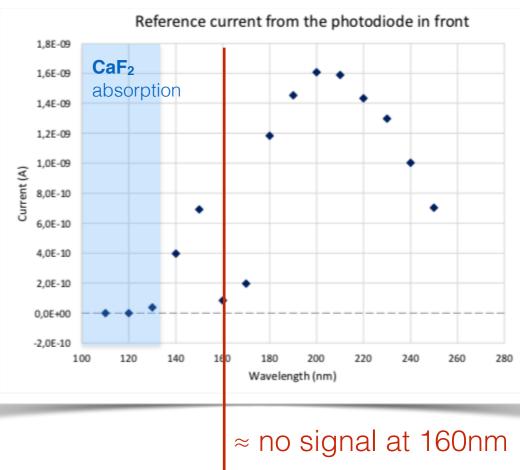
100V to 160V range to be remeasured with more data points

## Light spectrum

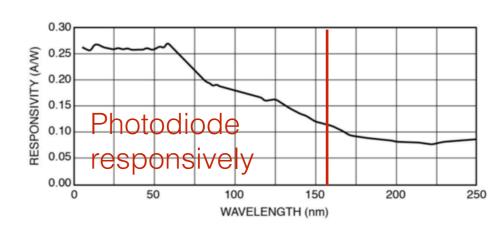
#### **Lamp** output spectrum



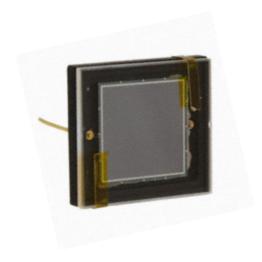
#### Measured **photodiode** response

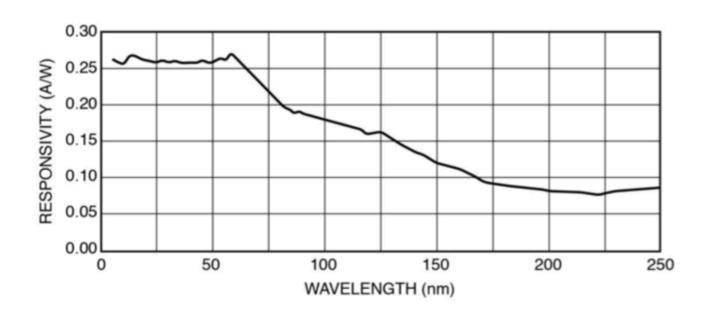


Measured photodiode current as function of wavelength does not match expected lamp spectrum



## Photodiode responsivity





Responsitivity of photodiode converted to quantum efficiency to determine incident number of photons

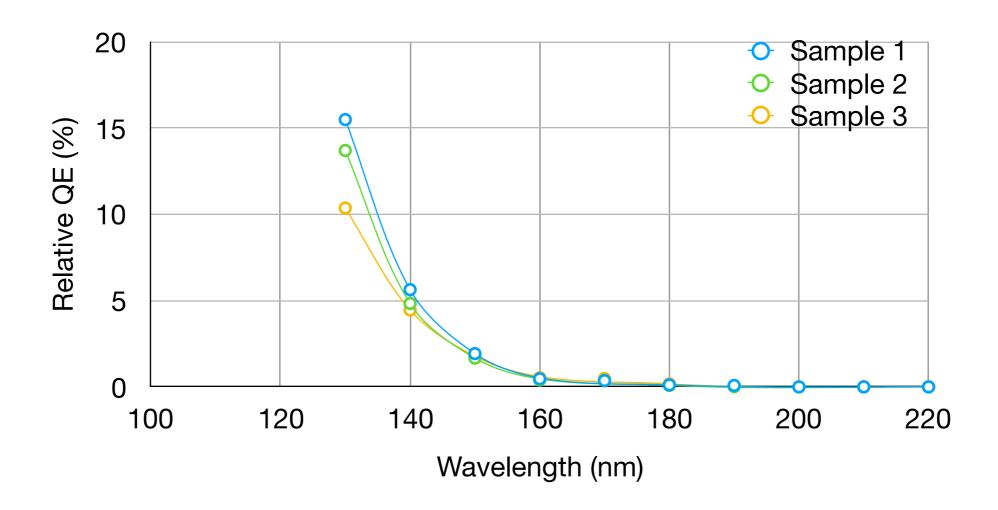
$$QE_{\lambda} = rac{R_{\lambda}}{\lambda} imes rac{hc}{e} pprox rac{R_{\lambda}}{\lambda} imes (1240 ext{ W} \cdot ext{nm/A})$$

Dividing recorded photocurrent (number of electrons) on extraction mesh by incident number of photons

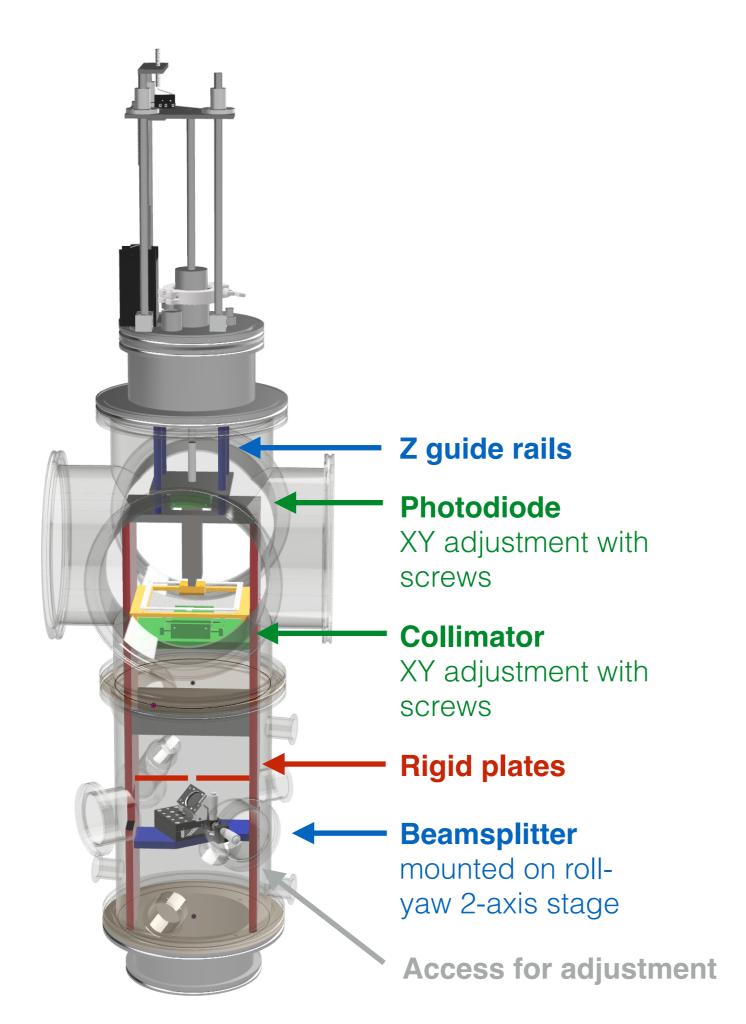
### First relative measurements

3 Csl photocathodes (previously used in PicoSec test beam)

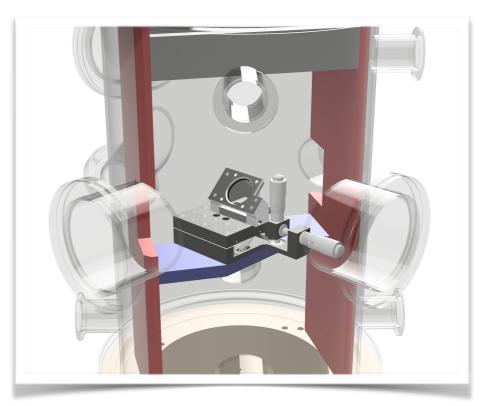
3mm MgF<sub>2</sub> window + 3nm Cr + 18nm Csl



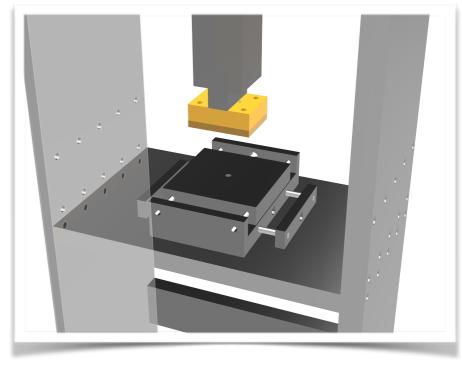
Next steps



### Optical axis



Roll-yaw 2-axis beamsplitter movement



XY collimator movement

## Optical axis





#### **Photodiode**

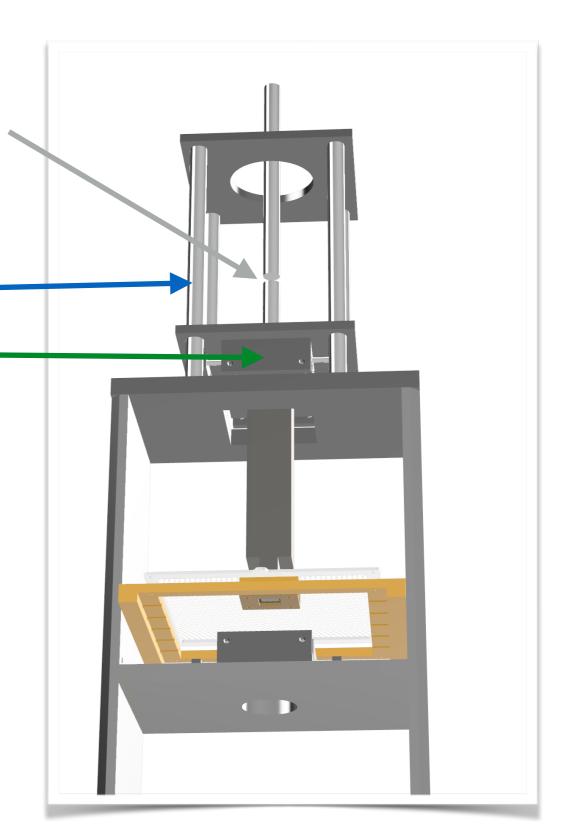
XY adjustment with screws

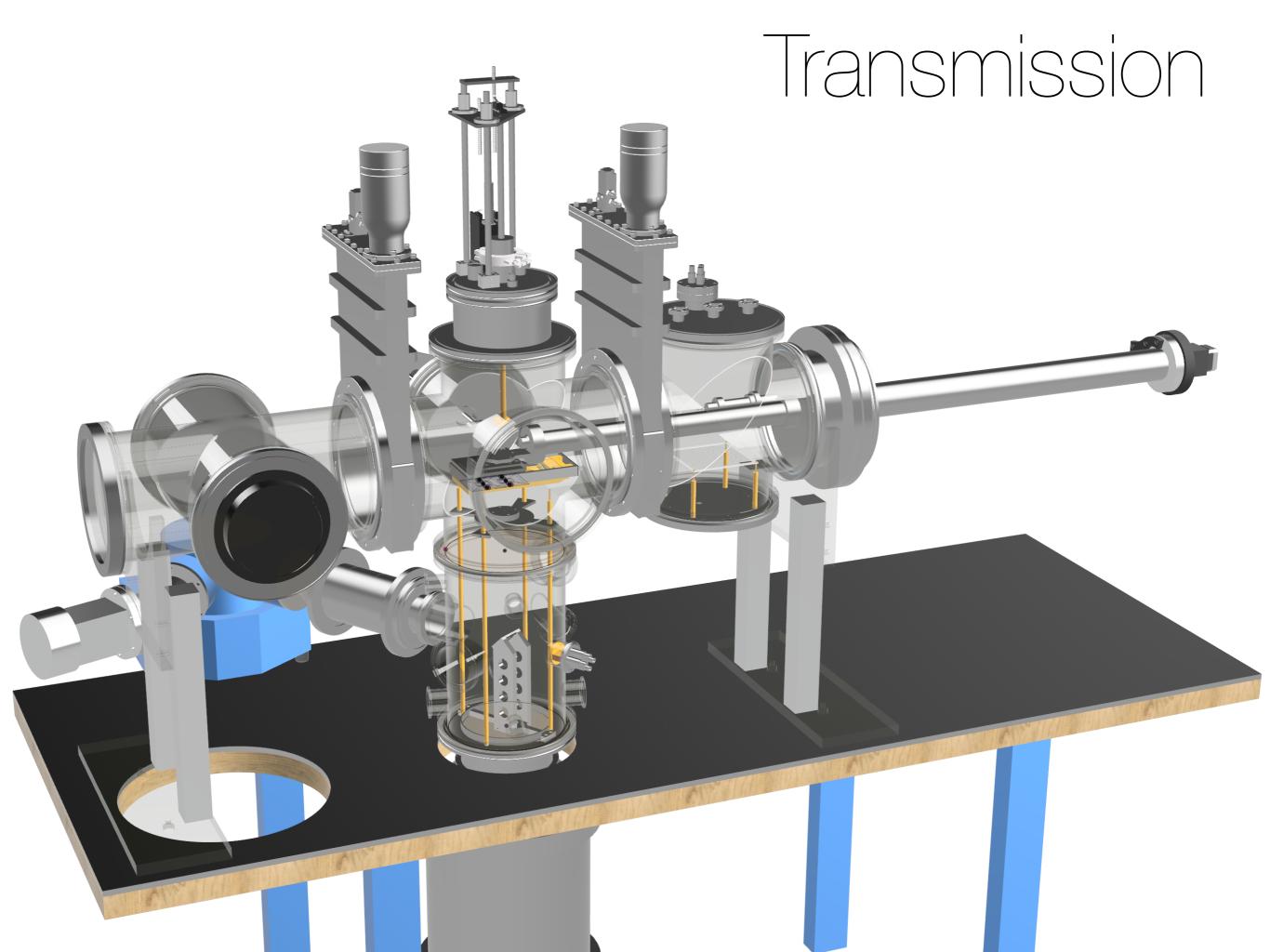
#### **Collimator**

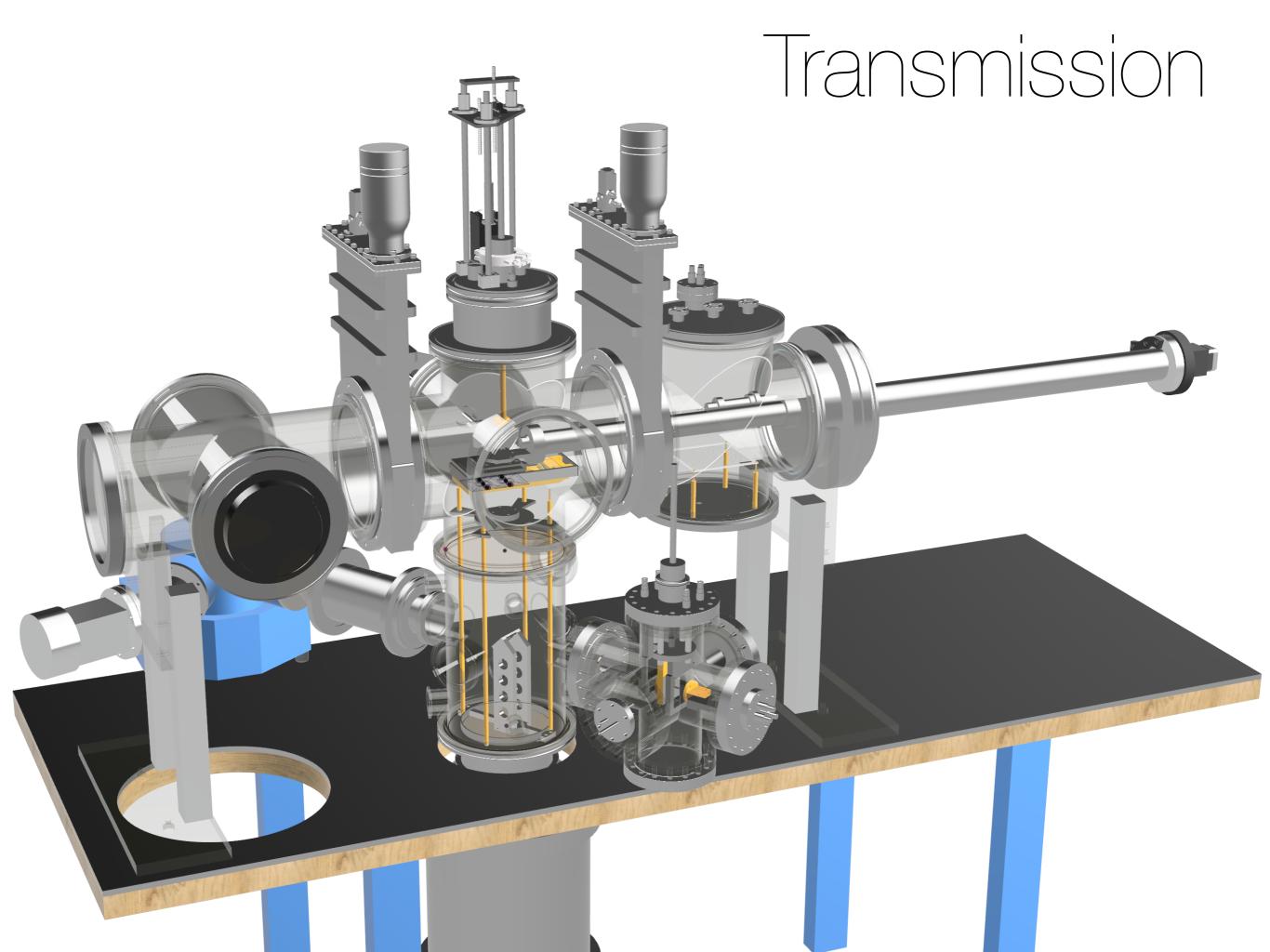
XY adjustment with screws

#### **Beamsplitter**

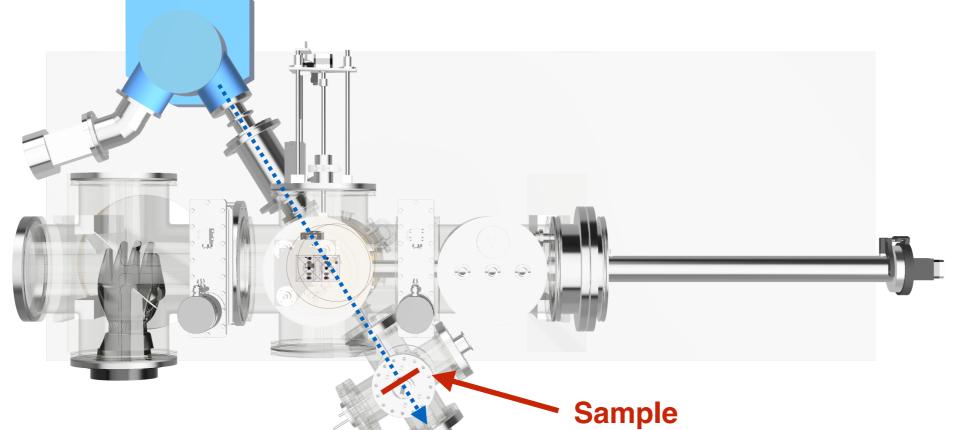
mounted on rollyaw 2-axis stage







## Transmission

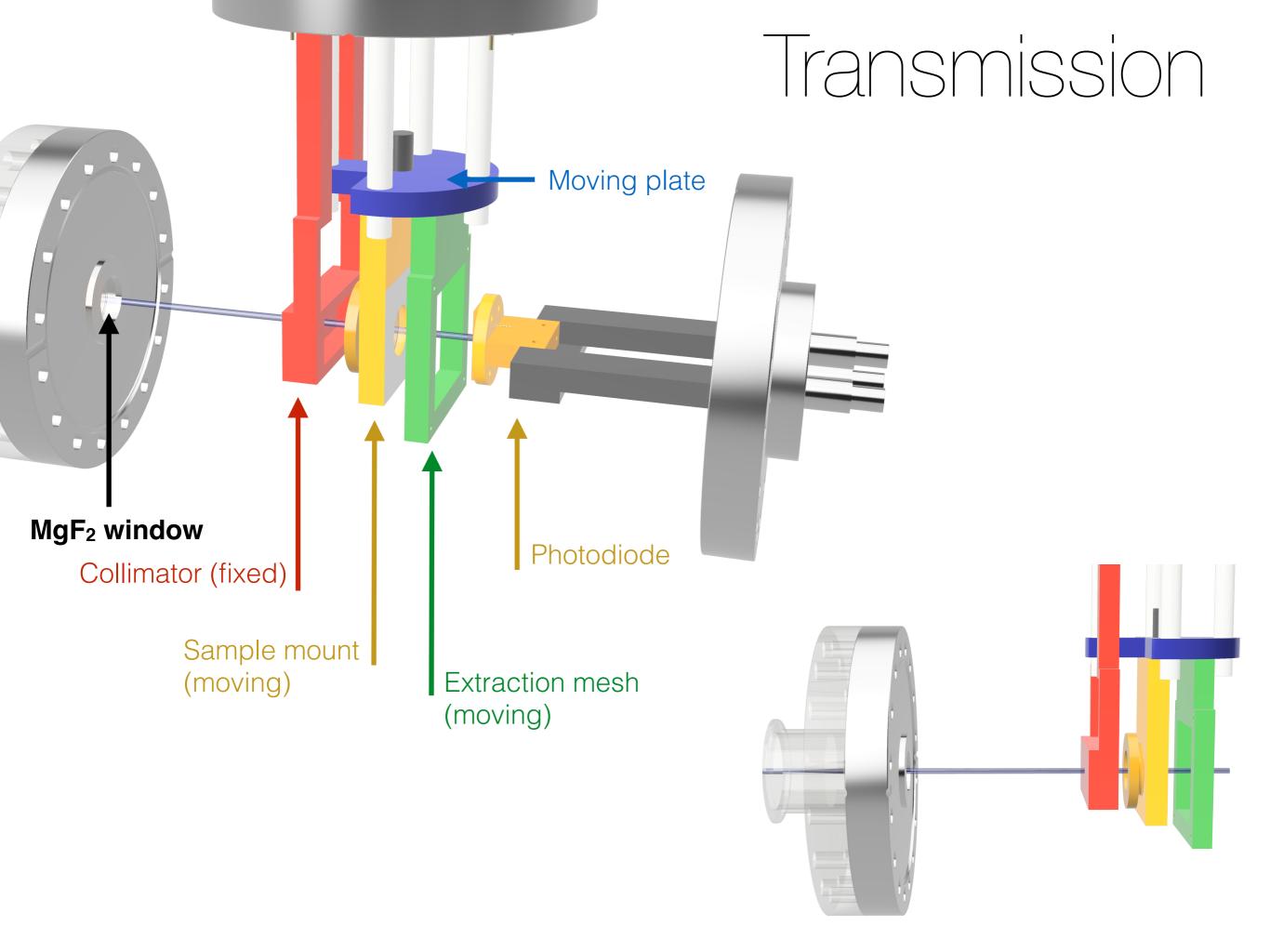


MgF<sub>2</sub> window

to separate volumes and preserve vacuum in main chamber

measured in transmission mode





### Calibration PMT

**CsI PMT** 

with MgF<sub>2</sub> window, calibrated response as absolute reference

May be mounted instead of reference photodiode

